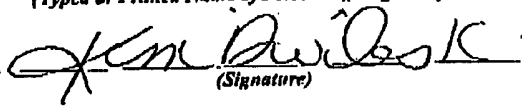


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P. 01

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. BUR920010184US2
Applicant(s): Geiss et al.			
Application No. 10/695,336	Filing Date 10/28/2003	Examiner Nema O. Berezny	Group Art Unit 2813
Invention: METHOD OF CONTROLLING GRAIN SIZE IN A POLYSILICON LAYER AND IN SEMICONDUCTOR DEVICES HAVING POLYSILICON STRUCTURES			
<p>I hereby certify that this <u>Request for Reconsideration (13 pages)</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>) on <u>7/5/2005</u> (Date)</p> <p style="text-align: right;"><u>Kim Dwileski</u> (Typed or Printed Name of Person Signing Certificate)  (Signature)</p> <p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>			

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P. 02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/695,336

Applicant(s): Geiss et al.

Filed.: October 28, 2003

Art Unit: 2813

Dkt. No.: BUR920010184US2

Examiner: Nema O. Berezny

Title: **METHOD OF CONTROLLING GRAIN SIZE IN A POLYSILICON LAYER AND
IN SEMICONDUCTOR DEVICES HAVING POLYSILICON STRUCTURES**

Honorable Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

This Request for Reconsideration is being filed in response to the Office Action mailed on April 20, 2005. Applicants request this Amendment be entered in the above-identified application and reconsideration of the application in view of the Amendments and Remarks that follow.

S/N 10/695,336

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